

Application/Control No.	Applicant(s)/Patent under Reexamination
10/755,844	AHRENS ET AL.
Examiner	Art Unit
Lex Maisawma	2823

Lex Maisawma

	SEAR	CHED	
Class	Subclass	Date	Examiner
438	626 631 639 642 643 644 645 648	4/23/2005	BVK
438	687 627 628	5/1/2005	BVK
above	UPDATED	3/3/2006	LHM
above	UPDATED	9/23/2006	LHM
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INI	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
438	643	9/23/2006	LHM		

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
EAST, DERWENT, EPO, JPO, USPUBS, US PATS, IBM TDB	4/23/2005	BVK
ALL UPDATED.	8/23/2005	BVK
PGPUB text search September 23, 2006, see interference search printout.	9/23/2006	LHM